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CONFIRMATION NO. 6996

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|--|---|-------------------------------|---|---|--------------------------------|
| SERIAL NUMBER 10/665,897 | FILING OR 371(c) DATE 09/18/2003 RULE | CLASS 257 | GROUP ART UNIT 2822 | ATTORNEY DOCKET NO. NSC1P282/P05730 | |
| APPLICANTS Peter J. Hopper, San Jose, CA; Iouri Mirgorodski, Sunnyvale, CA; Vladislav Vashchenko, Palo Alto, CA; Peter Johnson, Sunnyvale, CA; | | | | | |
| ** CONTINUING DATA ***** <i>KR none</i> | | | | | |
| ** FOREIGN APPLICATIONS ***** <i>KR none</i> | | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/11/2003 | | | | | |
| Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>KR Rose</i> Examiner's Signature Initials | | STATE OR COUNTRY CA | SHEETS DRAWING 5 | TOTAL CLAIMS 25 | INDEPENDENT CLAIMS 2 |
| ADDRESS 022434 | | | | | |
| TITLE Apparatus and method for forming heat sinks on silicon on insulator wafers | | | | | |
| FILING FEE RECEIVED 840 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |